

PATENT APPLICATION

4319.70023

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant: Yuichiro Ohta

Serial No.: 10/796,344

Conf. No.: 1978

Filed: 3/9/2004

For: VACUUM PROCESSING
APPARATUS

Art Unit: 1763

Examiner: Lund, Jeffrie Robert

) I hereby certify that this paper is being deposited with the
) United States Postal Service as FIRST-CLASS mail in an
) envelope addressed to: Mail Stop Amendment, Commissioner
) for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on
) this date.

) March 16, 2006

) Date

) F-CLASS.WCM

) Appr. February 20, 1998

Joseph P. Soy
Registration No. 41,760
Attorney for Applicant(s)

AMENDMENT A

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed December 16, 2005, please amend
the application as follows: